

FORM PTO-1449 (Modified) LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT(S)' INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	ATTY. DOCKET NO. 6136/53755 (25916-111)	SERIAL NO. Unassigned
	APPLICANT Solomon I. Beilin, et al.	
	FILING DATE Filed Herewith	GROUP ART UNIT Unassigned

J0971 U.S. PTO
 09/881514
 06/12/01

REFERENCE DESIGNATION U.S. PATENT DOCUMENTS

EXAM'R INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	Subclass	Filing Date If Appropriate
SA	A1	4,181,755	1/1/80	Liu, et al.	430	314	
	A2	4,307,179	12/22/81	Chang, et al.	430	314	
	A3	4,622,058	11/11/86	Leary-Renick, et al.	65	105	
	A4	4,634,496	1/6/87	Mase, et al.	156	643	
	A5	4,795,722	1/3/89	Welch, et al.	437	192	
	A6	4,824,521	4/25/89	Kulkarni, et al.	156	643	
	A7	4,954,142	9/4/90	Carr, et al.	51	309	
	A8	4,981,553	1/1/91	Tytgat, et al.	156	666	
	A9	5,006,485	4/9/91	Villalon	437	195	
	A10	5,084,071	1/28/92	Nenadic, et al.	51	309	
	A11	5,091,339	2/25/92	Carey	437	187	
	A12	5,098,517	3/24/92	Tytgat, et al.	156	666	
	A13	5,118,385	6/2/92	Kumar, et al.	156	644	
	A14	5,137,597	8/11/92	Curry, II, et al.	156	636	
	A15	5,162,260	11/10/92	Leibovitz, et al.	437	195	
	A16	5,169,491	12/8/92	Doan	156	636	
	A17	5,217,586	6/8/93	Datta, et al.	204	129.6	
	A18	5,219,793	6/15/93	Cooper, et al.	437	195	
	A19	5,225,034	7/6/93	Yu, et al.	156	636	
✓	A20	5,244,534	9/14/93	Yu, et al.	156	636	
SA	A21	5,246,884	9/21/93	Jaso, et al.	437	225	

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SA	A22	5,258,096	11/2/93	Sandhu, et al.	156	643	
	A23	5,272,117	12/21/93	Roth, et al.	437	228	
	A24	5,284,548	2/8/94	Carey, et al.	156	630	
	A25	5,287,619	2/22/94	Smith, et al.	29	852	
	A26	5,298,463	3/29/94	Sandhu, et al.	437	192	
	A27	5,302,551	4/12/94	Iranmanesh, et al.	437	195	
	A28	5,314,843	5/24/94	Yu, et al.	437	225	
	A29	5,328,553	7/12/94	Poon	156	636	
	A30	5,332,467	7/26/94	Sune, et al.	156	636	
	A31	5,350,712	9/27/94	Shibata	437	195	
	A32	5,354,490	10/11/94	Yu, et al.	252	79.1	
	A33	5,354,712	10/11/94	Ho, et al.	437	195	
	A34	5,363,550	11/15/94	Aitken, et al.	29	828	
	A35	5,380,546	1/10/95	Krishnan, et al.	427	126.1	
	A36	5,389,194	2/14/95	Rostoker, et al.	156	636	
	A37	5,397,741	3/14/95	O'Connor, et al.	437	187	
	A38	5,429,987	7/4/95	Allen	437	187	
	A39	5,451,543	9/19/95	Woo, et al.	437	195	
✓	A40	5,451,551	9/19/95	Krishnan, et al.	437	241	
SA	A41	5,453,402	9/26/95	Cheung, et al.	437	195	

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FOREIGN PATENT DOCUMENTS

EXAM'R INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	Subclass	TRANSLAT'N	
							yes	no
	B1							

OTHER ART (Include Author, Title, Date, Pertinent Pages, Etc.)

SA	C1	Andrew R. Fee, et al., "Rockwell Hardness Testing," <i>ASM Handbook</i> , Vol. 8, Mechanical Testing, The Materials Information Society, pgs. 74-83, 109-113. NOV, 1989
	C2	T.A. Shankoff, et al., "High Resolution Tungsten Patterning Using Buffered, Mildly Basic Etching Solutions," <i>J. Electrochem. Soc.: SOLID STATE SCIENCE AND TECHNOLOGY</i> , Feb., 1975, pgs. 297-298.
	C3	<i>Materials Handbook for Hybrid Microelectronics</i> , Teledyne Microelectronics, Los Angeles, CA 1988, pg. 476.
	C4	<i>Goodfellow Metals and Materials for Research and Industry</i> , Catalog, 1992-1993, 6 pgs.
	C5	<i>Handbook of Plastics, Elastomers, and Composites</i> , Second Edition, Technology Seminars, Inc., Lutherville, Maryland, 1992, 4 pages.
✓	C6	Second Edition, <i>CRC Materials Science and Engineering Handbook</i> , CRC Press, 1994, 3 pgs.
SA	C7	<i>Semiconductor International</i> , "CMP: Suppliers Integrating, Applications Spreading," Nov. 1995, pgs. 74-82.

EXAMINER <i>Shamir Alid</i>	DATE CONSIDERED <i>9/19/02</i>
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